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CPA/1763/17

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Docket No. A-64833-1/MSS/WEN

Anticipated Classification of this
Application:

Class: Subclass:

Prior Application

Examiner: LUND, R

Art Unit: 1763

Box CPA FEE

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

This is a request for filing a Continued Prosecution Application under 37 C.F.R. 1.53(d) of pending application Serial No. 09/457,929 filed on December 8, 1999 in the name of Jack Chihchieh Yao; Robert Jeffrey Bailey (Names of ALL Applicants) for WAFER CARRIER AND SEMICONDUCTOR APPARATUS FOR PROCESSING A SEMICONDUCTOR SUBSTRATE (Title of Invention).

(PLEASE NOTE: FILING OF THIS FORM RESULTS IN AUTOMATIC ABANDONMENT OF THE PARENT APPLICATION. THIS FORM CANNOT BE USED AFTER THE ISSUE FEE IN THE PARENT APPLICATION HAS BEEN PAID. THIS FORM CANNOT BE USED FOR PRIORITY APPLICATIONS FILED AFTER MAY 29, 2000.)

1. _____ Applicant claims small entity status. See 37 CFR 1.27.

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Form 1.16b (8068)

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10. _____ Request and Certification under 35 U.S.C. 122(b)(2)(B)(i) with attached form PTO/SB/35 or its equivalent.

Date: August 21, 2001

Signature: _____

William E. Nuttle, Reg. No. 42,943

Address of Signer: _____

Inventor(s)

FLEHR HOHBACH TEST ALBRITTON
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Assignee of complete interest

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Filed under Section 1.34(a)